



AMENDMENT / RESPONSE TRANSMITTAL

Applicant : Sophie et al.
 App. No. : 09/975,466
 Filed : October 9, 2001
 For : IN SITU REDUCTION OF
 COPPER OXIDE PRIOR TO
 SILICON CARBIDE
 DEPOSITION
 Examiner : Kielin
 Art Unit : 2813

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

October 10, 2003

(Date)

Andrew N. Merickel, Reg. No. 53,317

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing in the above-identified application are the following enclosures:

(X) Response to Office Action in 2 pages.

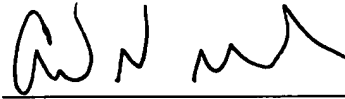
The fee has been calculated as shown below:

FEE CALCULATION				
FEE TYPE		FEE CODE	CALCULATION	TOTAL
Total Claims	21 - 32 = 0	1202 (\$18)	0 x 18 =	\$0
Independent Claims	2 - 4 = 0	1201 (\$84)	0 x 84 =	\$0
Multiple Claim		1203 (\$280)		\$0
1 Month Extension		1251 (\$110)		\$0
2 Month Extension		1252 (\$410)		\$0
3 Month Extension		1253 (\$930)		\$0
			TOTAL FEE DUE	\$0

(X) Return prepaid postcard.

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- (X) Please charge any additional fees, including any fees for additional extension of time, or credit overpayment to Deposit Account No. 11-1410.



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